

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
)
	Tetsuro Inui et al.)
)
Serial No.:	10/624,082) Art Unit
) 2613
Filing Date:	July 21, 2003)
)
Confirmation No.:	5995)
)
For:	DISPERSION MONITORING METHOD AND)
	APPARATUS AND DISPERSION SLOPE)
	TEMPERATURE DEPENDENCY COMPENSATION)
	METHOD AND APPARATUS)
)
Examiner:	Hibret Asnake Woldekidan)

AMENDMENT "C" AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Examiner:

Applicant submits this paper in response to the Office Action mailed January 26, 2009.

Reconsideration is respectfully requested in view of the following remarks:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.